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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO
10/608,081	06/30/2003	Kye Nam Lee	40296-0024	7874
26633	7590 04/17/2006		EXAMINER	
	HRMAN WHITE & MO	VINH, LAN		
	E ISLAND AVE, NW		1271217	D. 200 . U.D. (D. D.
WASHINGTON, DC 20036-3001			ART UNIT	PAPER NUMBER
			1765	

DATE MAILED: 04/17/2006

Please find below and/or attached an Office communication concerning this application or proceeding.

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-		Application No.	Applicant(s)				
Office Action Summary		10/608,081	LEE ET AL.				
		Examiner	Art Unit	 -			
		Lan Vinh	1765				
Period fo	The MAILING DATE of this communication ap or Reply	ppears on the cover sheet	with the correspondence address -	•			
THE - External after - If the - If NC - Failu Any	ORTENED STATUTORY PERIOD FOR REPI MAILING DATE OF THIS COMMUNICATION nsions of time may be available under the provisions of 37 CFR 1 SIX (6) MONTHS from the mailing date of this communication. period for reply specified above is less than thirty (30) days, a reported for reply is specified above, the maximum statutory period reto reply within the set or extended period for reply will, by staturely received by the Office later than three months after the mailined patent term adjustment. See 37 CFR 1.704(b).	136(a). In no event, however, may ply within the statutory minimum of d will apply and will expire SIX (6) No te, cause the application to become	a reply be timely filed thirty (30) days will be considered timely. ONTHS from the mailing date of this communical ABANDONED (35 U.S.C. § 133).	tion.			
Status							
. 1)⊠	Responsive to communication(s) filed on 22 l	March 2006					
·	This action is FINAL . 2b) ☐ This action is non-final.						
	3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is						
,—	closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.						
Dispositi	on of Claims						
5)□ 6)⊠ 7)□	Claim(s) 1-3 is/are pending in the application. 4a) Of the above claim(s) is/are withdra Claim(s) is/are allowed. Claim(s) 1-3 is/are rejected. Claim(s) is/are objected to. Claim(s) are subject to restriction and/	awn from consideration.					
Applicati	on Papers						
9)□	The specification is objected to by the Examin	er.					
· -	10) The drawing(s) filed on is/are: a) accepted or b) objected to by the Examiner.						
	Applicant may not request that any objection to the		•				
	Replacement drawing sheet(s) including the correct	ction is required if the drawi	ng(s) is objected to. See 37 CFR 1.121	1(d).			
11)	The oath or declaration is objected to by the E	Examiner. Note the attach	ed Office Action or form PTO-152.				
Priority u	ınder 35 U.S.C. § 119						
a)[Acknowledgment is made of a claim for foreig All b) Some * c) None of: 1. Certified copies of the priority document 2. Certified copies of the priority document 3. Copies of the certified copies of the priority document application from the International Bureate the attached detailed Office action for a list	nts have been received. Its have been received in ority documents have be au (PCT Rule 17.2(a)).	Application No. <u>10/608,081</u> . en received in this National Stage				
Attachmen	· Ne\						
_	u(s) e of References Cited (PTO-892)	4) \square Intervie	w Summary (PTO-413)				
2) Notic Notic Notic	e of Draftsperson's Patent Drawing Review (PTO-948) nation Disclosure Statement(s) (PTO-1449 or PTO/SB/08 r No(s)/Mail Date	Paper N	o(s)/Mail Date f Informal Patent Application (PTO-152)				

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DETAILED ACTION

Claim Rejections - 35 USC § 102

1. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

- (e) the invention was described in (1) an application for patent, published under section 122(b), by another filed in the United States before the invention by the applicant for patent or (2) a patent granted on an application for patent by another filed in the United States before the invention by the applicant for patent, except that an international application filed under the treaty defined in section 351(a) shall have the effects for purposes of this subsection of an application filed in the United States only if the international application designated the United States and was published under Article 21(2) of such treaty in the English language.
- 2. Claims 1, 3 are rejected under 35 U.S.C. 102(e) as being anticipated by Schwarz (US 6,972,265)

Schwarz discloses a method for fabricating an MTJ stack/ cell comprising the steps of:

forming a metal layer 26 connected to a semiconductor substrate 22 through a lower dielectric/ insulating layer (col 7, lines 30-32)

sequentially forming a pinned magnetic layer 28, a tunnel barrier layer 32 and free magnetic layer 34 on the metal layer 26 (col 8, lines 30-32; col 9, lines 46-48) forming a metal layer 36/hard mask layer on the magnetic layer 34 (col 10, lines 44-48; fig. 4)

the hard mask layer 36 and the free magnetic layer 34 are patterned using an etching step and MTJ cell mask 38 as seen in fig. 4, the tunnel barrier layer 32 is exposed after the patterning step (col 11, lines 10-15)

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sequentially forming a barrier layer 42 and insulating layer 50 of silicon oxide claim 3 on the entire surface (col 12, lines 50-55, col 15, lines 4-6)

anisotropically etching the insulating film to form an insulating spacer on a sidewall of the layer 36/hard mask, magnetic layer 34 and barrier layer 32 (col 15, lines 5-20; fig. 8) etching the tunnel layer 32, the pinned magnetic layer 28 and metal layer 42 using the insulating spacer and the hard mask layer as a mask to define/form MTJ cell and a connection layer (col 13, lines 1-22, fig. 6a)

Claim Rejections - 35 USC § 103

- 3. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 4. Claim 2 is rejected under 35 U.S.C. 103(a) as being unpatentable over Schwarz (US 6,972,265) in view of Parkin et al (US 6,518,588)

Schwarz's method has been described above. Unlike the instant claimed invention as per claim 2, Schwarz fails to disclose forming a Ta barrier layer and an insulating oxide film

Parkin discloses a method for forming a MRAM comprises the steps forming a TaN barrier layer and a insulating oxide film (col 3, lines 34-35, col 6, lines 9-10)

Since both Schwarz and Parkin are directed to method of forming magnetic semiconductor device, one skilled in the art at the time the invention was made would

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have found it obvious to modify Schwarz by forming a barrier layer of Ta in view of Parkins teaching because Parkin discloses that TaN which acts as a thermal diffusion barrier are also useful for magnetic tunnel junction device (col 6, lines 66-67)

Response to Arguments

5. Applicant's arguments filed 3/22/2006 have been fully considered but they are not persuasive.

In response to the argument that although the Examiner has indicated that claim 3 is rejected, no art has been cited against claim 3, it is noted that the claimed feature of claim 3/an oxide insulating film is taught in the reference of Schwarz as clearly indicated by upper-case letter in line 8 on page 2 of the previous office action

The applicants argue that Schwarz fails to specifically disclose "sequentially forming a barrier layer and an insulating film on the entire surface because as shown in Figs. 5-8 of Schwarz, neither barrier layer/spacer 42 nor barrier layer/spacer 50 is formed over the entire surface of the device. This argument is unpersuasive because while it is true that neither spacer 42 nor spacer 50 is formed over the entire surface of the device as shown in Figs 5, 8, it is also true that Schwarz discloses forming the spacers by depositing the dielectric materials over the semiconductor topography/device and then etching the dielectric materials to form the spacer (col 12, lines 50-55, col 15, lines 4-6). Thus Schwarz teaching of depositing the dielectric materials 42, 50 over the semiconductor topography/device, before the etching steps to

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form the spacer, certainly reads on the claimed step of "sequentially forming a barrier layer and an insulating film on the entire surface"

The applicants further argue that Schwarz does not disclose "etching the hard mask layer and the free magnetic layer in a photolithography process using a MTJ cell mask to expose the tunnel barrier layer" because in Schwarz the alleged hard mask layer 36 as well as MTJ cell mask 38 are not removed and are present when the barrier layer 42 is formed as shown in Figs. 4-8. This argument is unpersuasive because as disclosed in col 11, lines 10-15 and shown in fig. 4 of Schwarz, the hard mask layer 36 and the free magnetic layer 34 are patterned using an etching step and MTJ cell mask 38 to expose the tunnel barrier layer 32 as required in claim 1

6. **THIS ACTION IS MADE FINAL.** Applicant is reminded of the extension of time policy as set forth in 37 CFR 1.136(a).

A shortened statutory period for reply to this final action is set to expire THREE MONTHS from the mailing date of this action. In the event a first reply is filed within TWO MONTHS of the mailing date of this final action and the advisory action is not mailed until after the end of the THREE-MONTH shortened statutory period, then the shortened statutory period will expire on the date the advisory action is mailed, and any extension fee pursuant to 37 CFR 1.136(a) will be calculated from the mailing date of the advisory action. In no event, however, will the statutory period for reply expire later than SIX MONTHS from the mailing date of this final action.

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Conclusion

7. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Lan Vinh whose telephone number is 571 272 1471. The examiner can normally be reached on M-F 8:30-5:30 PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Nadine Norton can be reached on 571 272 1465. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

LV

April 14, 2006